

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of: Latchford, et al.

Serial No.: 09/921,938

Confirmation No.: 8367

Filed: August 2, 2001

For: Photolithography Scheme Using a

Silicon Containing Resist

Box AF

Assistant Commissioner for Patents

Washington, D.C. 20231

Group Art Unit:

1752

Examiner:

A. C. Walke

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CERTIFICATE OF MAILING 37 CFR 1.8

I hereby certify that this correspondence is being deposited on October 7, 2002 with the United States Postal Service as First Class Mail in an envelope addressed to: Box AF Commissioner for Patents, Washington, D.C. 20231.

10/7/02

Signature

Dear Sir:

NOTICE OF APPEAL

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the decision of the Examiner dated May 6, 2002, finally rejecting claims 1-44. A duplicate copy of this sheet is enclosed.

The fee for this Notice of Appeal (37 CFR § 1.17(b)) is \$320.00. The Commissioner is hereby authorized to charge \$320.00 for the Notice of Appeal and any additional fees which may be required, or credit any overpayment to Deposit Account No. 20-0782/4227.P1/DSM/BCVD/KMT.

Respectfully submitted,

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